

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Gi-Jung Kim et al.  
Serial No. 10/601,475  
Filed: June 23, 2003

Confirmation No. 7249  
Group Art Unit: 1775  
Examiner: Elizabeth D. Ivey

For: **SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES  
THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING  
PARTICULATE CONTAMINATION AND METHODS OF FORMING SAME**

July 31, 2006

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1451

**RESPONSE TO NOTICE OF NON-RESPONSIVE AMENDMENT**

Sir:

Applicants respectfully submit that Applicants' Amendment A of May 1, 2006 is fully responsive to the Official Action of February 3, 2006. In this Amendment A, Claims 11-14, which were the only claims subject to prior art rejections, were canceled. Accordingly, Applicants' remarks did not need to address the prior art rejections when Applicants' Amendment A was filed.

Based on these comments, Applicants respectfully request entry of the Amendment A of May 1, 2006 and further examination of the present application.

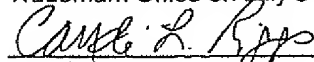
Respectfully submitted,

  
Grant E. Scott  
Registration No. 36,925

**USPTO Customer No. 20792**  
Myers Bigel Sibley & Sajovec  
Post Office Box 37428  
Raleigh, North Carolina 27627  
Telephone: 919/854-1400  
Facsimile: 919/854-1401

**CERTIFICATION OF ELECTRONIC TRANSMISSION**

I hereby certify that this correspondence is being transmitted electronically to the U.S. Patent and Trademark Office on July 31, 2006.

  
Candi L. Riggs